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PATENT

DOCKET: CU 2636

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application: Sang Ick LEE et al.

Serial No.: 09/994,284

Filed: November 26, 2001

For: METHOD OF FORMING METAL GATE IN
SEMICONDUCTOR DEVICE

GRP ART UNIT

Ex

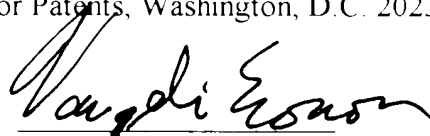
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Certification under 37 C.F.R. §1.8(a)

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Vangelis Economou

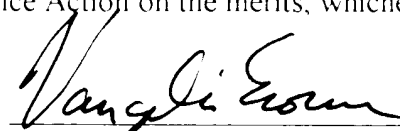
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**TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT WITHIN THREE MONTHS
OF FILING OR BEFORE MAILING OF FIRST OFFICE ACTION**

Sir:

The information disclosure statement submitted herewith is being filed within three months of the filing date of the application or date of entry into the national stage of an international application or before the mailing date of the first Office Action on the merits, whichever event occurs last. 37 CFR 1.97(b).

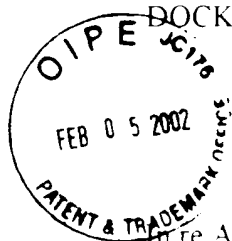
December 12, 2001


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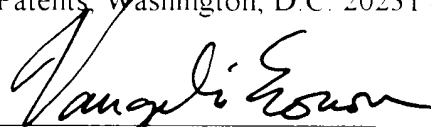
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Vangelis Economou

THE COMMISSIONER FOR PATENTS
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Applicants submit herewith copies of seven U.S. Patents and two Japanese patent applications of which the applicants are aware, and which may be material to the examination of this application and in respect of which there may be a duty to disclose under 37 CFR 1.56.

The filing of this information disclosure statement shall not be construed as a representation that a search has been made (37 CFR 1.97(g)), an admission that the information cited is, or is considered to be, material to patentability or that no other material information exists.

The filing of this information disclosure statement shall not be construed as an admission against interest in any manner. Notice of January 9, 1992, 1135 O.G. 13-25, at 25.

The references submitted herewith are listed on PTO-Form 1449 (modified) attached hereto. A copy of each reference listed patent is being furnished.

Additional comments, if any, on the relevance of each reference listed are provided as follows:

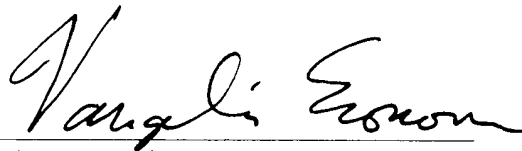
Full translations of the Japanese Patent applications, No. 2000-12538 and 2001-36083 are not readily available, but English language Abstracts of these applications are attached to each to indicate the relevance, if any.

The Statement is made on the basis of the information

_____	supplied by the inventor(s),
<u> X </u>	supplied by an individual associated with the filing and prosecution
_____	of this application (37 CFR 1.56(c)), or
_____	in the attorney's file.

12/12/01
Date

Respectfully submitted,



Signature of Attorney
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